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Attorney Docket No. 291958171US4
SEMITOOL REF No. P98-0025US8

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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: LINLIN CHEN ET AL.

APPLICATION No.: 10/695,419

FILED: OCTOBER 27, 2003

FOR: **APPARATUS AND METHOD FOR
ELECTROLYTICALLY DEPOSITING
COPPER ON A SEMICONDUCTOR
WORKPIECE**

EXAMINER: PHUC T. DANG

ART UNIT: 2818

CONF. No: 4483

Amendment in Response to Restriction Requirement

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 24, 2004, please amend the application as reflected in the following listing of claims.